

INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application No.	10/582,588	
	Filing Date	June 9, 2006	
	First Named Inventor	Williams et al.	
	Art Unit	Unknown	
(Multiple sheets used when necessary)		Examiner	Unknown
SHEET 1 OF 1		Attorney Docket No.	DAVI258.003APC

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number <i>Number - Kind Code (if known)</i> Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	4,586,164	04-29-1986	Eden Dayton D	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document <i>Country Code-Number-Kind Code</i> Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	2	JP 60 180886	09-14-1985	Fujitsu Ltd.		

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	3	KAILER A. et al., "Phase transformations of silicon caused by contact loading" © 1997 American Institutes of Physics: J Appl. Phys. Vol. 81, No. 7, 1 April 1997, pgs 3057-3063	
	4	Suppl. European Search Report, EP 04 80 2037, Date: 6/28/2007.	

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Examiner Signature	Date Considered
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

T¹ - Place a check mark in this area when an English language Translation is attached.